




PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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R.L. Milton

Appl No. : 10/090,915 Confirmation No. 7688
Applicant : Konstantin Holdermann
Filed : March 5, 2002
Title : ETCHING SOLUTION FOR WET CHEMICAL PYRAMIDAL TEXTURE
ETCHING OF SILICON SURFACES

TC/A.U. : 1765
Examiner : Shamim Ahmed

Docket No. : 47585/RAG/S969
Customer No. : 23363

AMENDMENT AND REQUEST FOR RECONSIDERATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Post Office Box 7068
Pasadena, CA 91109-7068
February 12, 2004

Commissioner:

In response to the Office action of August 14, 2003, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.